

Amendment to the Claims

This listing of claims replaces all prior versions, and listings, of claims in the application.

Listing of Claims

1-6. Canceled

7. (Original) A semiconductor wafer-holding jig used in a heating furnace, comprising:

a gas introduction hollow conduit disposed along the longitudinal direction of the heating furnace; and

a wafer-holding jog disposed on the front end of said gas introduction hollow conduit, comprising a wafer-holding portion which includes an ejection hole for ejecting a gas to the semiconductor wafer from said gas introduction hollow conduit.

8. (Original) The semiconductor wafer-holding jig as claimed in claim 7, which is used in a vertical heating furnace.

9. (Original) The semiconductor wafer-holding jig as claimed in claim 7, which is used in a horizontal heating furnace.